



10/643,534.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cyril Cabral Jr., et al.

Docket: 16695

Patent No.: 6,943,097

Dated: March 06, 2006

Issued: September 13, 2005

**For: ATOMIC LAYER DEPOSITION OF
METALLIC CONTACTS, GATES AND
DIFFUSION BARRIERS**

Certificate

MAR 15 2006

of Correction

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

REQUEST FOR CERTIFICATE OF CORRECTION

Sir:

**It appears that errors have been introduced in the course of printing
the Patent issued in the above application, and it is respectfully requested that the
Commissioner issue a Certificate of Correction in the following respects:**

Column 4, Line 21:

"thereof An" should read -- thereof. An --

Respectfully submitted,

**Leslie S. Szivos
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**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**

PATENT NO : 6,943,097
APPLICATION NO : 10/643,534
ISSUE DATE : September 13, 2005
INVENTOR(S) : Cyril Cabral Jr., et al.

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 4, Line 21:
"thereof An" should read -- thereof. An --

MAILING ADDRESS OF SENDER:

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PATENT No. 6,943,097

No. of additional copies

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